



IFW

IBM Docket No. FIS920030146US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: **Stephen W. Bedell et al.**

Serial No.: **10/604,989**

Date: **November 10, 2004**

Filed: **August 29, 2003**

Group Art Unit: **2881**

Title: **AN ELECTRON MICROSCOPE
MAGNIFICATION STANDARD
PROVIDING PRECISE CALIBRATION
IN THE MAGNIFICATION RANGE
5000X-200,000X**

Examiner: **Jack I. Berman**

DeLIO & PETERSON, LLC
121 Whitney Avenue
New Haven, CT 06510-1241

LETTER TO OFFICIAL DRAFTSMAN

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants are herewith submitting 5 sheets of Formal Drawings for the approval of the Draftsman.

Please charge the Assignee IBM Corporation Deposit Account No. **09-0458** for any fee related to the acceptance of the attached Formal Drawings. A duplicate copy of this letter is enclosed for that purpose.

Respectfully submitted,

BY:


Attorney: **Kelly M. Reynolds**
Registration No. **47,898**
(203) 787-0595